



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/526,800 Confirmation No. 7409

Applicants : Anatoly L. Vikharev, Aleksey M. Gorbachev, Aleksandr G. Litvak, Jurii V. Bykov, Grigory G. Denisov, Oleg A. Ivanov and Vladimir A. Koldanov

Filed : March 7, 2005

Title : HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD

TC/A.U. : 1792

Examiner : Rakesh Kumar Dhingra

Docket No. : IOAP 4.1-1

Customer No. : 21036

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action mailed March 4, 2009, Applicants amend and remark as follows:

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.